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Appl. No. : 10/023,940 Confirmation No. 7717
Applicant : Jin-goo PARK
Filed : December 21, 2001
TC/A.U. : 1746
Examiner : Michail Kornakov

Docket No. : 1751-0297
Cust. No. : 06449

Mail Stop Non-fee Amendment

Commissioner for Patents
P.O. Box 1450
Alexandria VA 22313-1450

RESPONSE TO RESTRICTION REQUIREMENT

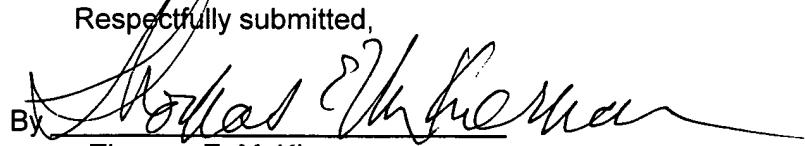
Assistant Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

In response to the restriction requirement mailed February 17, 2004, the Applicants hereby elect Group II, consisting of claims 3 and 4, drawn to a method of cleaning a wafer, classified in class 134, subclass 1. Applicant reserves the right to pursue the non-elected claims in a divisional application.

Favorable action on the elected claims is earnestly solicited.

Respectfully submitted,

By 
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